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| FORM PTO-1449 | | Docket Number (Optional) 81872.0053 | | Application Number <u>Not assigned</u> | | |
| INFORMATION DISCLOSURE CITATION IN AN APPLICATION | | Applicant Yasuhiko SHIMOTSUMA et al. | | | | |
| (Use several sheets if necessary) | | Filing Date September 9, 2003 | | Group Art Unit <u>2883</u> <u>Not assigned</u> | | |
| U.S. PATENT DOCUMENTS | | | | | | |
| EXAMINER INITIAL | DOCUMENT NUMBER | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
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| FOREIGN PATENT DOCUMENTS | | | | | | |
| | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION (YES/NO) |
| BMT | 2000-193823 | 07/14/00 | Japan | 385 | 37X | Abstract |
| BMT | 2001-066428 | 03/16/01 | Japan | 385 | 37X | Abstract |
| BMT | 2001-004817 | 01/12/01 | Japan | 385 | 37X | Abstract |
| BMT | 10-282337 | 10/23/98 | Japan | 385 | 37X | Abstract |
| BMT | 11-352327 | 12/24/99 | Japan | 385 | 37X | Abstract |
| BMT | 11-167024 | 06/22/99 | Japan | 385 | 37X | Abstract |
| BMT | 2001-083321 | 03/30/01 | Japan | 385 | 37X | Abstract |
| BMT | 2002-311242 | 10/23/02 | Japan | 385 | 37X | Abstract |
| BMT | 2003-066232 | 03/05/03 | Japan | 385 | 37X | Abstract |
| BMT | 2003-057442 | 02/26/03 | Japan | 385 | 37X | Abstract |
| OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | |
| BMT | Toshiaki KONDO et al., "Femtosecond Laser Interference Technique with Diffractive Beam Splitter for Fabrication of Three-Dimensional Photonic Crystal", Applied Physics Letters, Vol. 79, No. 6, August 6, 2001, pp. 725-727. | | | | | |
| BMT | Ken-ichi Kawamura et al., "Holographic Encoding of Fine-Pitched Micrograting Structures in Amorphous SiO ₂ Thin Films on Silicon by a Single Femtosecond Laser Pulse", Applied Physics Letters, Vol. 78, No. 8, February 19, 2001 pp.1038-1040 | | | | | |
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| EXAMINER | B. Healy | | DATE CONSIDERED 4/11/07 | | | |
| EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant. | | | | | | |